



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815

Examiner: Mr. Joseph H. Nguyen

In re PATENT APPLICATION of:

Applicant : Takashi NOGUCHI)
Serial No. : 10/822,691)
Filed : April 13, 2004)
For : HEAT RADIATION)
STRUCTURE OF)
SEMICONDUCTOR DEVICE,)
AND MANUFACTURING)
METHOD THEREOF)
Attorney Ref. : OKI 419)

**INFORMATION
DISCLOSURE
STATEMENT**

March 14, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

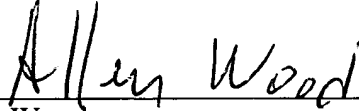
Sir:

This is an Information Disclosure Statement submitted under 37 CFR 1.97-1.98, filed concurrently with a Request for Continued Examination (RCE).

A Form PTO -1449 and copies of the references listed therein are attached. Three of the references are written in the Japanese language and accompanied by Patent Abstracts of Japan summaries to provide English-language information about the relevance of the references. The final two references are Japanese 11-54896 and US 6,228,466, which appears to be the counterpart of Japanese 11-54896 and is submitted to provide English-language information about Japanese 11-54896.

In view of the foregoing, it is respectfully requested that the reference be considered
and made of record.

Respectfully submitted,

A handwritten signature in cursive script that reads "Allen Wood". The signature is written in dark ink and is positioned above a horizontal line.

Allen Wood

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FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT

Atty. Docket:

Application No.:

OKI 419

10/822,691

Applicant:

Takashi NOGUCHI

Filing Date:

April 13, 2004

Group Art Unit:

2815

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	6,228,466	05/08/2001	Tsukada et al			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	11-54896	02/26/1999	Japan			No
	AJ	11-67998	03/09/1999	Japan			Abstract
	AK	2001-250872	09/14/2001	Japan			Abstract
	AL	2002-329939	11/15/2002	Japan			Abstract
	AM						

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AN	
	AO	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.